

Docket No.: MIT-7581L

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Joseph B. Bernstein and Zhihui Duan

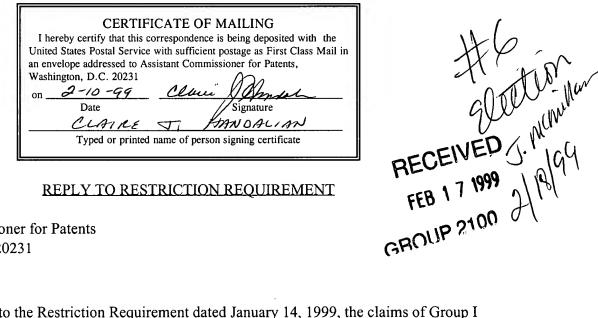
Application No.: 08/825,808

Group Art Unit: 2812

Filed: April 3, 1997

Examiner: L. Gurley

For: LASER-INDUCED CUTTING OF METAL INTERCONNECT



REPLY TO RESTRICTION REQUIREMENT

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Responsive to the Restriction Requirement dated January 14, 1999, the claims of Group I (Claims 20-41) drawn to a method of making a semiconductor device are elected for prosecution. Applicant reserves the right to file a continuing application or take such other appropriate action as deemed necessary to protect the invention of Group II (Claims 1-19). Applicant does not hereby abandon or waive any rights in the Group II invention.

Respectfully submitted,

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